



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Bruce et al. Examiner: Turner, S.  
Serial No.: 09/386,112 Group Art Unit: 2877  
Filed: August 30, 1999 Docket No.: AMDA.261PA  
(TT2335)  
Title: DUAL-DIFFERENTIAL INTERFEROMETRY FOR SILICON DEVICE  
DAMAGE DETECTION

TECHNOLOGY CENTER 8800

JAN - 07 2003

RECEIVED

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this communication is being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 19 2002.

By:

Kelly Waltigny

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.136, it is respectfully requested that a one-month extension of time be granted in which to file the attached Notice of Appeal. Please charge Deposit Account No. 01-0365 (TT2335) in the amount of \$110 to cover the extension fee for a large entity. Authority is given to charge/credit necessary fees/overages to Deposit Account No. 01-0365 (TT2335) as required by this filing.

12/30/2002 JADD01 00000126 010365 09386112  
02 FC:1251 110.00 CH

CRAWFORD MAUNU PLLC  
1270 Northland Drive, Suite 390  
St. Paul, MN 55120  
(651) 686-6633

Respectfully Submitted,

By:

Name: Robert J. Crawford  
Reg. No.: 32,122